

Drw



PATENT
Customer No. 22,852
Attorney Docket No. 05225.0254

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
)
 Takeshi Shibata et al.) Group Art Unit: 1756
)
 Application No.: 10/743,290) Examiner: Young, Christopher G.
)
 Filed: December 23, 2003) Confirmation No.: 7857
)
 For: METHOD FOR FABRICATING)
 SEMICONDUCTOR DEVICE AND)
 EQUIPMENT FOR FABRICATING)
 THE SAME)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

RESPONSE TO RESTRICTION REQUIREMENT

In a Restriction Requirement mailed October 12, 2006, having a period for response extending through November 13, 2006 (November 12 being a Sunday), the Examiner required restriction under 35 U.S.C. § 121 between the following groups of claims:

Group I, claims 1-12, characterized by the Examiner as being drawn to a method for fabricating a semiconductor device; and

Group II, claims 13-14, characterized by the Examiner as being drawn to a a method for fabricating a semiconductor device.

Applicants provisionally elect to prosecute Group I, claims 1-12, without traverse.

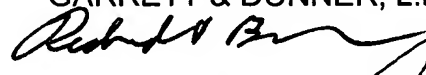
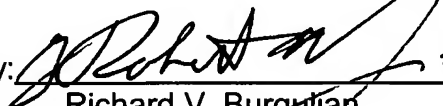
Please grant any extensions of time required to enter this response and charge any additional required fees to our deposit account 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,
GARRETT & DUNNER, L.L.P.

Dated: November 13, 2006

By:


 #27,432
Richard V. Burguljian
Reg. No. 31,744